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 Amane Mochizuki
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 EXAMINER

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ART UNIT PAPER NUMBER

MCCLENDON, SANZA L

1711

DATE MAILED: 12/30/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

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			on N .	Applicant(s)	<i>V</i>	
Office Action Commence		10/736,52	10/736,529 MOCHIZUKI ET AL.			
	Office Action Summary	Examin r		Art Unit		
	ι	Sanza L N		1711		
Period fo	 The MAILING DATE of this communication a or Reply 	appears on the	e c ver sheet with the	correspondence addres	is	
THE - Exte after - If th - If NO - Failt Any	MAILING DATE OF THIS COMMUNICATION MAILING DATE OF THIS COMMUNICATION PRINTS OF THIS COMMUNICATION PRINTS (6) MONTHS from the mailing date of this communication e period for reply specified above is less than thirty (30) days, a reperiod for reply is specified above, the maximum statutory period for reply within the set or extended period for reply will, by start reply received by the Office later than three months after the managed patent term adjustment. See 37 CFR 1.704(b).	N. 2 1.136(a). In no ever reply within the state iod will apply and within the app	ent, however, may a reply be ti utory minimum of thirty (30) da Il expire SIX (6) MONTHS fron lication to become ABANDON	mely filed ys will be considered timely. n the mailing date of this commu	nication.	
Status						
1)⊠	Responsive to communication(s) filed on 17	7 December 2	003.			
•	This action is FINAL . 2b)⊠ This action is non-final.					
3)□	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.					
Disposit	ion of Claims					
4)⊠	☑ Claim(s) <u>5-10</u> is/are pending in the application.					
	4a) Of the above claim(s) is/are withdrawn from consideration.					
5)	Claim(s) is/are allowed.					
6)⊠	6)⊠ Claim(s) <u>5-10</u> is/are rejected. 7)□ Claim(s) is/are objected to.					
7)						
8)□	8) Claim(s) are subject to restriction and/or election requirement.					
Applicat	ion Papers			•		
9)[The specification is objected to by the Exami	iner.				
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.						
	Applicant may not request that any objection to the					
	Replacement drawing sheet(s) including the corre	rection is require	ed if the drawing(s) is of	jected to. See 37 CFR 1.	.121(d).	
11)	The oath or declaration is objected to by the	Examiner. No	ote the attached Office	e Action or form PTO-1	52.	
Priority (under 35 U.S.C. § 119					
a)	Acknowledgment is made of a claim for foreign All b) Some * c) None of: 1. Certified copies of the priority docume 2. Certified copies of the priority docume 3. Copies of the certified copies of the priority docume application from the International Bure See the attached detailed Office action for a li	ents have bee ents have bee riority docume eau (PCT Rule	n received. n received in Applicatents have been receive e 17.2(a)).	tion No. <u>09/721,666</u> . red in this National Staç	је	
		227	,			
Attachmer	nt(s)	•				
	ce of References Cited (PTO-892)		4) Interview Summary	/ (PTO-413)		
2) D Notic	ce of Draftsperson's Patent Drawing Review (PTO-948)		Paper No(s)/Mail D	oate		
	mation Disclosure Statement(s) (PTO-1449 or PTO/SB/0 er No(s)/Mail Date <u>12/03</u> .	08)	5) Notice of Informal I	Patent Application (PTO-152)	

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DETAILED ACTION

Priority

1. Acknowledgment is made of applicant's claim for foreign priority under 35 U.S.C. 119(a)-(d). The certified copy has been filed in parent Application No. 09/721,666, filed on November 27, 2000. Applicant cannot rely upon the foreign priority papers to overcome this rejection because a translation of said papers has not been made of record in accordance with 37 CFR 1.55. See MPEP § 201.15.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claim 1·10 is rejected under 35 U.S.C. 103(a) as being unpatentable over Tani et al (5,972,807) in view of Yamamoto et al (6,387,969).

Tani et al teaches a film forming, photosensitive, heat-resistant resin composition including a varnish of a polyimide precursor, a polymerizable monomer, and a polymerization initiator. Tani et al teaches in one embodiment preparing a solution of finely divided particles of an acrylic resin or a phosphazene resin (polymerizable resin) in solution with the polyamic acid which comprises a tetracarboxylic acid dianhydride, aromatic diamine, and polyhydric amine as principle components; evaporating any solvent off causing a particle in matrix microstructure comprising a polyamic acid and a curable

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resin, wherein the polyamic is the matrix portion and the curable resin portions are the particles; then subjecting the polyamic acid to a cyclodehydration reaction to form the polyimide resin. In addition, Tani et al describes that the curable resin portions of the particle in matrix can be selectively cured in selective areas of the structure, and then the polyamic acid and uncured particle regions in areas other than areas that have been selectively cured area (i.e., non-selective areas) can be selectively eluted from the non-selective areas of the structure thereby forming patterns of the particle-in-matrix microstructure. Once this is done the polymer-in-matrix can be subjected to the cyclodehydration reaction to form a patterned polyimide resin film. Tani et al does not expressly teach a step of removing the curable resin, however Tani et al discloses that the size of the phase of curable resin (particles) can be optionally changed depending upon the desired results and other factors because the particles can be reduced with increased temperature and time for the evaporation or heating steps.

Yamamoto et al teaches porous articles and processes for producing said porous article that can be utilized as internal insulators, buffering materials, or circuit substrates and substrates for printed wiring boards in electronic/electrical appliances and electronic parts. Yamamoto et al teaches when an additive, such as polyurethane acrylates, are added to an polymer composition, such as a polyimide precursor, forms a specific microdomain structure The polymer base, which constitutes the continuous phase, can be a polyimide that is obtained by reaction of an organic dianhydride and diamine to synthesize the polyimide precursor and then subjecting said precursor to dehydrating ring closure (curing). The additive and the polymer are dissolved in a solvent and the solution is cast into form, such as a film or sheet. Thereafter the solvent is removed by drying to insolubilize the additive contained in the polymer material, thus a polymer composition which has micro-domain structure is obtained comprising a continuous phase made of the polymer and dispersed therein a discontinuous phases made of additive having an average diameter smaller than 10 \(\sigma\)m. Next, the additive is removed by a combination of at least one operation selected from vaporization and decomposition and an extraction operation while utilizing differences between the additive and the polymer in volatility or thermal decomposability and in solubility in a solvent. As a result, extremely fine cells are formed and a low dielectric constant can be obtained in the film.

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Tani et al and Yamamoto et al are analogous art because they are from the same field of endeavor that is the art of photosensitive films from use in electronic applications. Therefore, it would have been obvious for a person of ordinary skill in the art to prepare a photosensitive film from a photosensitive composition comprising a polyamic acid, polymerizable monomer, and a polymerization initiator, such as taught by Tani et al, evaporating the solvent from a solution of the previous defined composition to form a continuous phase (polymer phase) and discontinuous phase (monomer particles), such as taught by Tani et al and Yamamoto et al, selectively curing the particles by exposure and developing the non-selectively cured areas, as taught by Tani et al, evaporating the polymer particles, as taught by Yamamoto et al, and finally curing the polyamic acid to obtain a patterned polyimide photosensitive film for using as insulators or other applications of electronic parts. The motivation would have been a reasonable expectation of obtaining a photosensitive film for use in electronic applications having relaxed stress of the film, as taught by Tani et al, and having a low dielectric constant as suggested by Yamamoto et al in the absence of evidence to the contrary and/or unexpected results.

Claim Rejections - 35 USC § 112

- 4. The following is a quotation of the second paragraph of 35 U.S.C. 112:

 The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.
- 5. Claims 5-10 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.
- 6. Claim 5 recites the limitation "photosensitive composition according to claim 1" in line 2. There is insufficient antecedent basis for this limitation in the claim. Claim 1 has been cancelled so in effect there is not a photosensitive composition to refer to. However, in the interest of compact prosecution the examiner is using the composition as found in cancelled claim 1.

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Conclusion

7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Sanza L McClendon whose telephone number is (571) 272-1074. The examiner can normally be reached on Monday through Friday 7:30-4:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, James Seidleck can be reached on (571) 272-1078. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

PALMCCLENDON Sanza L McClendon

AL MOULTINER Examiner

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